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				Application Number	Not Yet Assigned 10/814,640
				Filing Date	April 1, 2004
				First Named Inventor	Sukesh Sandhu
				Art Unit	N/A 2825
Examiner Name	Not Yet Assigned C. Everhart				
Sheet	1	of	1	Attorney Docket Number	M4065.0224/P224-A

<b>U.S. PATENT DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
CTME	AA*	5,471,364	11/28/1995	Summerfelt, et al.	—
CTME	AB*	5,888,870	03/30/1999	Gardner, et al.	—
CTME	AC*	5,348,894	09/20/1994	Gnade, et al.	—
CTME	AD*	5,674,788	10/07/1997	Wristers, et al.	—
CTME	AE*	5,124,174	06/23/1992	Musket, et al.	—

<b>FOREIGN PATENT DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
					T <sup>6</sup>

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<b>NON PATENT LITERATURE DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
CTME	CA*	S. Wolf and R.N. Tauber, "Ion Implantation for VLSI," <i>Silicon Processing for the VLSI Era, Volume 1 – Process Technology, Chapter 9</i> , pages 280-327 (1986)			
CTME	CB*	S. Wolf and R.N. Tauber, "Suprem III Models: Ion Implantation," <i>Silicon Processing for the VLSI Era, Volume II, Chapter 9.2.2</i> , pages 658-661 (1986).			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*C. Musket* 9-13-04